OIP E VO	FILE GOPYReciept
DEC_1 2 2080tto hey's Docket No. 42390.P4222D2	PATENT 4 CFR
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE	
Re Application of:	31/2/01
Robert S. Chau, et al.	Examiner: Not yet assigned
Ü.S. Serial No: 09/654,315) Art Unit: Not yet assigned
Filed: September 1, 2000))
For: Device Structure And Method For Reducing Silicide Encroachment)) _)
Assistant Commissioner of Patents Washington, D.C. 20231	
REQUEST FOR CORRECTION	
Sir:	
In response to the Filing Receipt, the Applicant would like to request a correction	
to the spelling of one of the inventor's name. It is listed as Robert S. Chou. The correct	
spelling is Robert S. Chau. Enclosed is a copy of the Declaration/Power of attorney	
showing the correct spelling.	
Applicant respectfully requests correction of this error.	
	ctfully submitted, ELY, SOKOLOFF, TAYLOR & ZAFMAN LLP
·	el A. Bernadicou Jo. 35,934
12400 Wilshire Boulevard Seventh Floor Los Angeles, CA 90025-1026 (408) 720-8598 FIRST CLASS CERT	IFICATE OF MAILING
I hereby certify that this correspondence is being deposited with the postage in an envelope addressed to the Assistant Commissioner on	for Patents, Washington, D.C. 20231
Cindy Murphy Name of Person Mailing Correspondence	12/7/00
Signature (Date





COMMISSIONER FOR PATENTS UNITED STATES PATENT AND TRADEMARK OFFICE WASHINGTON, D.C. 20231

www.uspto.gov

TOT CLAIMS IND CLAIMS

APPLICATION NUMBER 09/654.315

S

FILING DATE 09/01/2000

GRP ART UNIT 2811

846

FIL FEE REC'D ATTY.DOCKET.NO DRAWINGS

42390.P4222D2 12

14

5

Michael A Bernadicou Blakely Sokoloff Taylor & ZAfman LLP 12400 Wilshire Boulevard 7th Floor Los Angeles, CA 90025

FILING RECEIPT

OC000000005522741

Date Mailed: 11/01/2000

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the PTO processes the reply to the Notice, the PTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Robert S. Chou, Beaverton, OR: Ebrahim Andideh, Portland, OR; Mitch C. Taylor, Lake Oswego, OR; Chia-Hong Jan, Portland, OR; Julie Tsai, Beaverton, OR;

REAKELY, SOKOLOFF, TAYLOR & ZAFMAN LOS ANGELES

OV 0 6 2000

RECEIVED

C ntinuing Data as Claimed by Applicant

THIS APPLICATION IS A DIV OF 09/115,405 07/14/1998 WHICH IS A DIV OF 08/884,912 06/30/1997

NOV 0 7 2000

B.S.T.Z. DATABASE DEPT. رح

Foreign Applications

If Required, Foreign Filing License Granted 11/01/2000

Title

Device structure and method for reducing silicide encroachment

Preliminary Class

257

ENTERED

NOV 0 6 2000

STATUS DB-LA

11/1/00